

Electronic Acknowledgement Receipt

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Application Number:	10530612
International Application Number:	
Confirmation Number:	6739
Title of Invention:	Plasma system and method for anisotropically etching structures into a substrate
First Named Inventor/Applicant Name:	Franz Laermer
Customer Number:	26646
Filer:	Gerard A. Messina/rita hannan
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Transmittal Letter	sids.pdf	176457 01e25665031b0490dcac01f373059fd9c6acd319	no	2

Warnings:

Information:

2	Foreign Reference	jp2003246023.pdf	1381090	no	10
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Warnings:					
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7	Foreign Reference	de19736370.pdf	703788	no	5
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8	Foreign Reference	de19539078.pdf	986480	no	11
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9	Foreign Reference	jp6314600.pdf	2924468	no	22
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.